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TRADE MARK OFFICE  
In re

# PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KIYOFUMI SAKAGUCHI, ET AL.

Application No.: 10/085,046

Filed: March 1, 2002

For: PROCESS FOR PRODUCTION OF  
SEMICONDUCTOR SUBSTRATE

Examiner: G. Fourson, III

Group Art Unit: 2823

March 28, 2005

**MAIL STOP AMENDMENT**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

## **AMENDMENT**

Sir:

In response to the Office Action dated January 26, 2005, reconsideration of the subject application is respectfully requested in view of the following amendments and remarks:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 28, 2005

(Date of Deposit)

Robert H. Fischer

(Name of Attorney for Applicant)

(Name of Attorney)

Robert A. Fischer

**Signature**

-May. 28, 2005

Date of Signature